

# LIST OF ART CITED BY APPLICANT

## (PTO-1449)

 ATTY. DOCKET NO.  
YHK-0123

 APPLN. SERIAL NO.  
10/743,782

 APPLICANT(S)  
Hun Gun PARK, Jae Hong LEE,  
Seok Dong KANG and Tae Su HWANG

 FILING DATE  
December 24, 2003

 GROUP  
2889

### U.S. PATENT DOCUMENTS

| EXAMINER'S INITIALS | *PATENT NO. | *ISSUE DATE | *INVENTOR NAME | CLASS | SUBCLASS | FILING DATE |
|---------------------|-------------|-------------|----------------|-------|----------|-------------|
|                     |             |             |                |       |          |             |
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### U.S. PATENT APPLICATION PUBLICATIONS

|  | *PATENT APPLN. PUB. NO. | *PUB. DATE | *APPLICANT | CLASS | SUBCLASS |  |
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### U.S. PATENT APPLICATIONS

|  | *APPLN. NO. | *FILING DATE | *INVENTOR | CLASS | SUBCLASS |  |
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### FOREIGN PATENT DOCUMENTS

| EXAMINER'S INITIALS | PATENT NO.     | DATE       | COUNTRY   | CLASS | SUBCLASS | Translation |    |
|---------------------|----------------|------------|---|-------|----------|-------------|----|
|                     |                |            |   |       |          | Yes         | No |
|                     | JP 2000-294154 | 10/20/2000 | Japan (English Abstract and Japanese Full Text) |       |          | X           |    |
|                     |                |            |   |       |          |             |    |
|                     |                |            |   |       |          |             |    |
|                     |                |            |   |       |          |             |    |

### OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

|  |  |
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|  | Japanese Office Action dated September 30, 2008. |
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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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